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PATENT NUMBER and ISSUE DATE					
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U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10051299	01/22/2002	385	37	2874	Tina Lin

**APPLICANTS: Ohmura Masaki; Shigehara Masakazu;

**CONTINUING DATA VERIFIED:

THIS APPLN CLAIMS BENEFIT OF 60/340,484 12/18/2001

** FOREIGN APPLICATIONS VERIFIED:

JAPAN P2001-209826 07/10/2001

JAPAN P2002-012017 01/21/2002

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiners's initials		<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no
ATTORNEY DOCKET NO 50212-338		
TITLE : Optical waveguide type defraction grating device and a method of manufacturing thereof U.S.DEP.T. OF COMM./PAT & TM-PTO-436L(Rev. 12-94)		

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED		
		Assistant Examiner		Total Claims Print Claim for O.G.
ISSUE FEE				DRAWING
Amount Due	Date Paid			Sheets Drwg. Figs.Drwg. Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		Primary Examiner		Application Examiner
PREPARED FOR ISSUE				
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